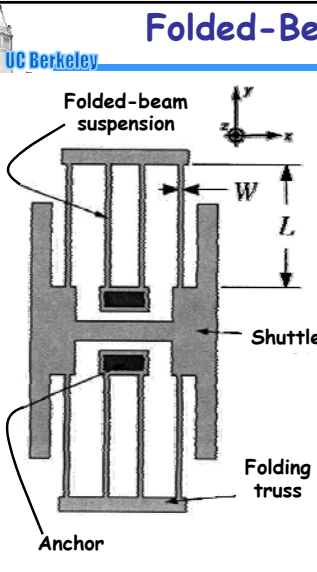


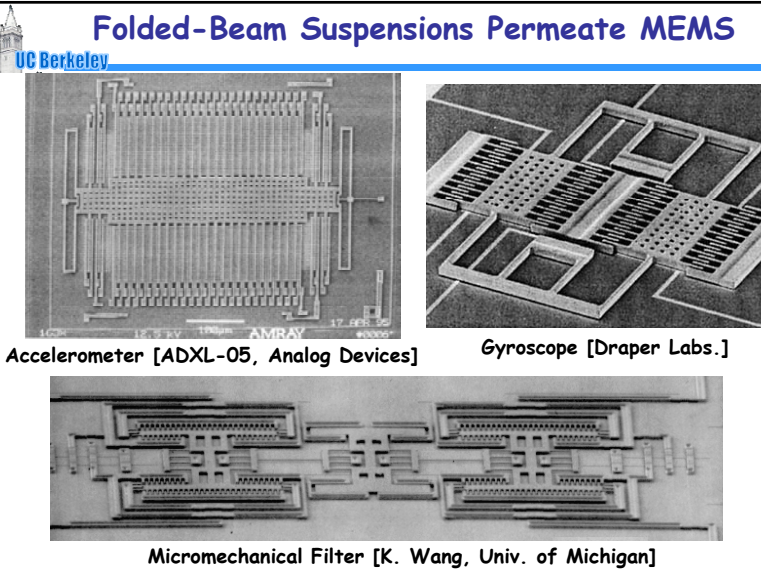
Folded-Beam Stiffness Ratios



- In the x-direction:
$$k_x = \frac{24EI_z}{L^3}$$
- In the z-direction:
Same flexure and boundary conditions
$$k_z = \frac{24EI_x}{L^3}$$
- In the y-direction:
[See Senturia, §9.2]
$$k_y = \frac{8EWh}{L}$$
- Thus:
$$\frac{k_y}{k_x} = 4 \left(\frac{L}{W} \right)^2$$
 Much stiffer in y-direction!

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Folded-Beam Suspensions Permeate MEMS



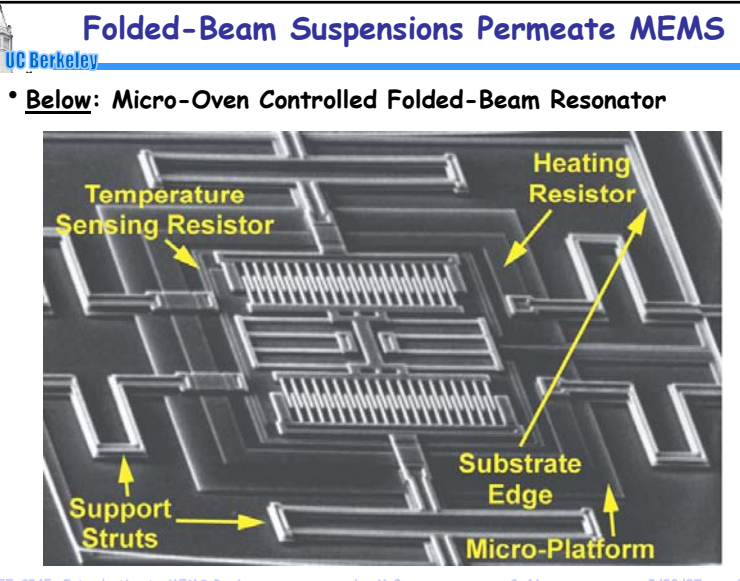
Accelerometer [ADXL-05, Analog Devices] Gyroscope [Draper Labs.]

Micromechanical Filter [K. Wang, Univ. of Michigan]

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Folded-Beam Suspensions Permeate MEMS

- Below: Micro-Oven Controlled Folded-Beam Resonator



Temperature Sensing Resistor Heating Resistor

Support Struts Substrate Edge Micro-Platform

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Stressed Folded-Flexures

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Clamped-Guided Beam Under Axial Load

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- Important case for MEMS suspensions, since the thin films comprising them are often under residual stress
- Consider small deflection case: $y(x) \ll L$



Governing differential equation: (Euler Beam Equation)

$$EI \frac{d^4 y}{dx^4} - S \frac{d^2 y}{dx^2} = F \delta(x-L)$$

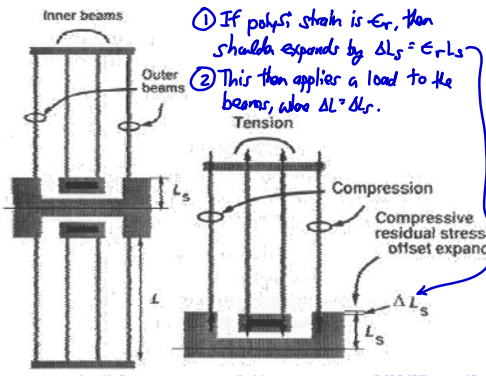
Axial Load
Unit impulse @ $x=L$

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Design Implications

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- Straight flexures**
 - Large tensile S means flexure behaves like a tensioned wire (for which $k^{-1} = L/S$)
 - Large compressive S can lead to buckling ($k^{-1} \rightarrow \infty$)
- Folded flexures**
 - Residual stress only partially released
 - Length from truss to shuttle's centerline differs by L_s for inner and outer legs



① If polyimide strain is ϵ_r , then shuttle expands by $\Delta L_s = \epsilon_r L_s$
 ② This then applies a load to the beams, where $\Delta L = \Delta L_s$.

③ Beam strain: $\epsilon_b = \frac{\Delta L}{L} = \frac{\Delta L_s}{L} = \epsilon_r \frac{L_s}{L}$

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